

# Temperature dependence of the hyperfine fields of $^{111}\text{In}$ in sapphire ( $\text{Al}_2\text{O}_3$ ) single crystals

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Michael Steffens<sup>1</sup>   Jakob Penner<sup>1</sup>   Hassan Kamleh<sup>2</sup>  
Reiner Vianden<sup>1</sup>

<sup>1</sup>Helmholtz - Institut für Strahlen- und Kernphysik, Universität Bonn, Germany

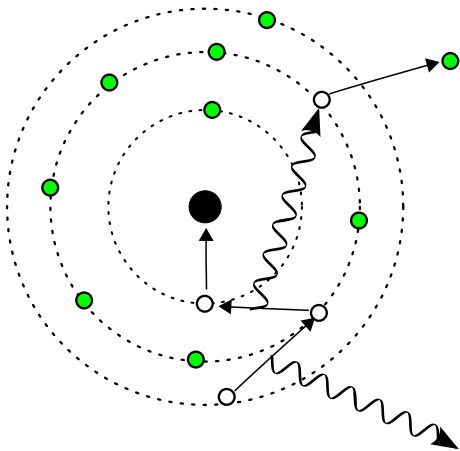
<sup>2</sup>Department of physics, Faculty of sciences, University of Damascus, Syria



# Introduction

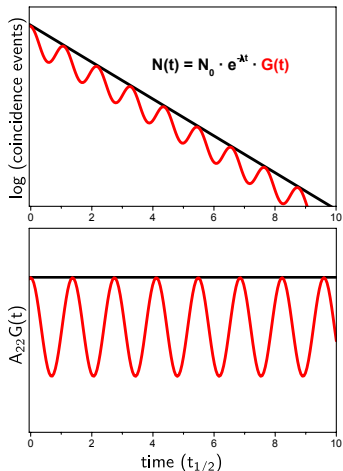
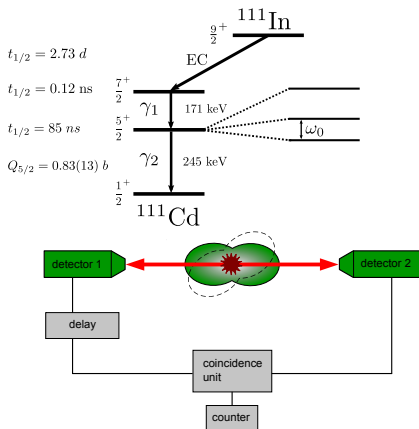
- ▶ Basing on previous measurements of undoped  $\text{Al}_2\text{O}_3$   
*Penner and Vianden, Hyperfine Interactions 158(1), 389 (2004)*
- ▶ Temperature dependent measurements of the electric field gradient (EFG) in doped  $\text{Al}_2\text{O}_3$
- ▶ Experimental technique: time-differential perturbed angular correlation (TDPAC)
- ▶ Investigation of the "electron capture after effect"
- ▶ Possible application: electron mobility studies in semiconductors and insulators

## Electron capture decay of $^{111}\text{In}$



- ▶  $(p) + e^{-} \longrightarrow (n) + \nu_e$
- ▶ Half life of the (highly) ionized state depending in the electronic surrounding
  - ▶ vacuum:  $t_{1/2}$  large
  - ▶ metallic:  $t_{1/2} \approx 10^{-12}$  s
  - ▶ insulating:  $t_{1/2} \approx 10^{-9}$  s, influenced by electron mobility and density

# Experimental technique: TDPAC

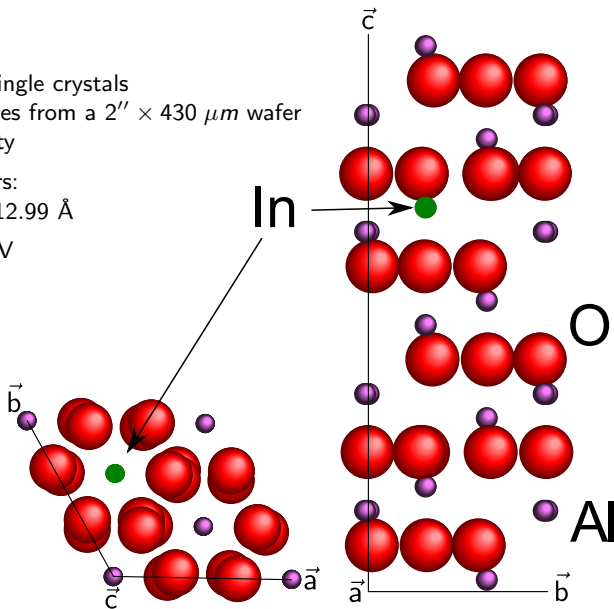


Hyperfine interaction of the EFG with the nuclear quadrupole moment  $Q$

$$\Rightarrow \text{Quadrupole interaction frequency } \nu_Q = \frac{eQV_{zz}}{h}$$

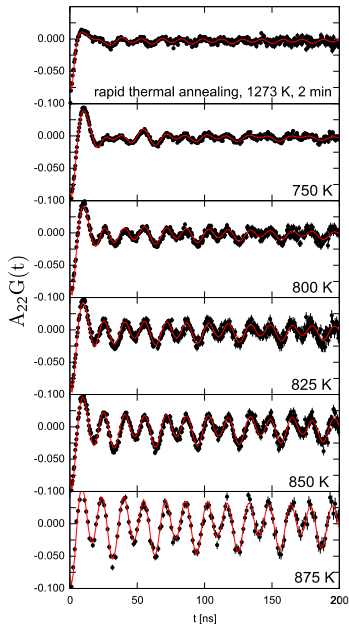
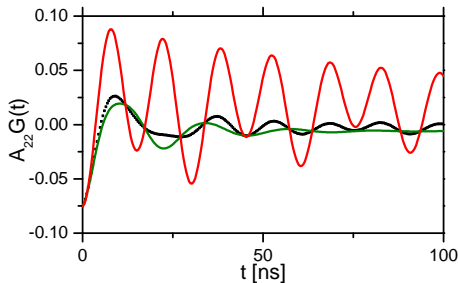
# Al<sub>2</sub>O<sub>3</sub>

- ▶ Material:  
(0001) oriented single crystals  
(5 × 5) mm<sup>2</sup> pieces from a 2'' × 430 μm wafer  
≈ 99.9999% purity
- ▶ Lattice parameters:  
a = 4.75 Å, c = 12.99 Å
- ▶ Bandgap = 9.9 eV



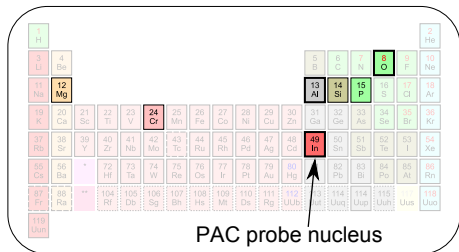
# $^{111}\text{In}$ in undoped $\text{Al}_2\text{O}_3$

- ▶ Ion implantation of  $^{111}\text{In}$  at BONIS (BONn Isotope Separator)
- ▶ Rapid thermal annealing ( $T_a = 1273\text{ K}$ , 2 min,  $\text{N}_2$ -flow)

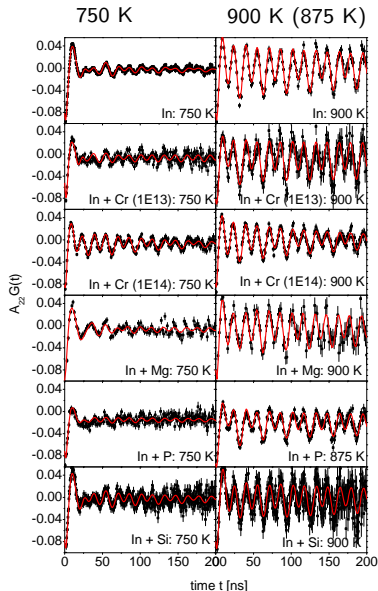


# Temperature dependence of the EFG in doped $\text{Al}_2\text{O}_3$

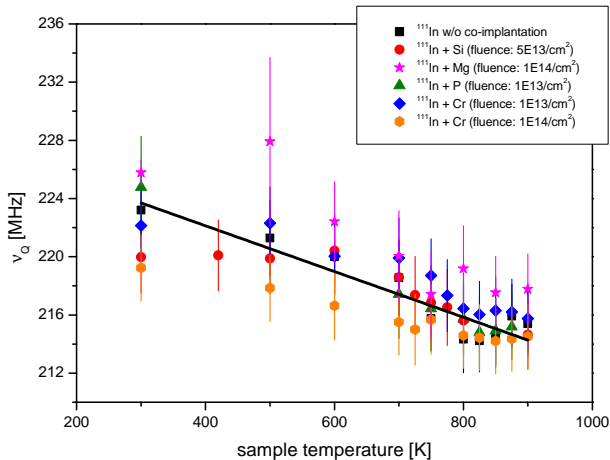
- ▶ Co-implantation with overlapping implantation profile



	Energy (keV)	Fluence (atoms/cm <sup>2</sup> )	Effective charge subst. Al
$^{111}\text{In} / ^{111}\text{Cd}$	160	$10^{12}$	ionized
Cr	80	$10^{13}/10^{14}$	isoelectronic
Mg	40	$10^{14}$	acceptor
P	60	$10^{13}$	double donor
Si	50	$5 \cdot 10^{13}$	donor



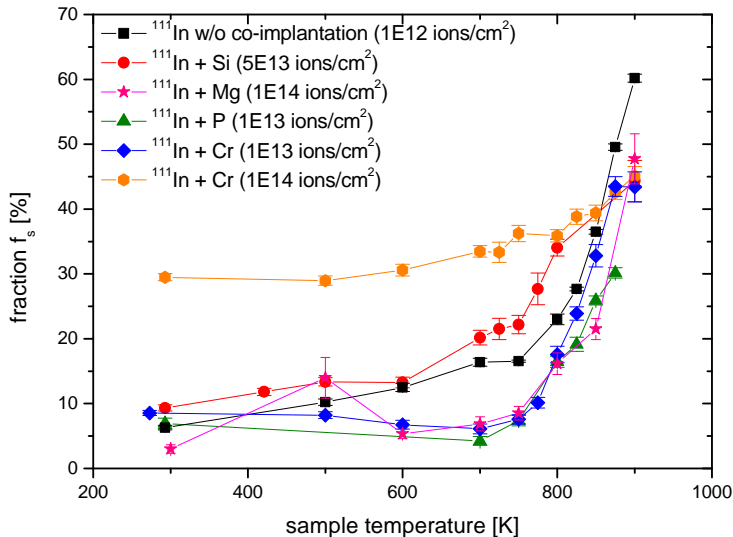
# Temperature dependence of $\nu_Q$



$$\nu_Q(T) = 228(2) \text{ MHz} - 1.6(3) \cdot 10^{-2} \text{ MHz/K} \cdot T$$



# Temperature dependance of the static interaction $f_s$



# Summary

- ▶ Characterization of the EFG in relation to the sample temperature in an insulator ( $\text{Al}_2\text{O}_3$ )
- ▶ Changes of this relation following doping of Cr, Mg, P and Si
  - ▶ Minor temperature dependence of  $\nu_Q$
  - ▶ Doping of Cr has a large impact at higher Cr fluences (fluence dependent effect)
- ▶ Relaxation of the atomic shell of  $^{111}\text{Cd}$  after electron capture gives us information about the electron mobility and the conductivity of the insulator